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IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
TAKEHIRO UEDA, ET AL. : EXAMINER: DAHIMENE, M.
SERIAL NO: 10/509,338 :
FILED: OCTOBER 8, 2004 : GROUP ART UNIT: 1765
FOR: METHOD FOR SUPPRESSING :
CHARGING OF COMPONENT IN
VACUUM PROCESSING CHAMBER OF
PLASMA PROCESSOR AND PLASMA
PROCESSOR

REQUEST FOR RECONSIDERATION UNDER 37 C.F.R. § 1.111

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated June 15, 2006, Applicants respectfully request reconsideration of the above-identified application in view of the following remarks.

Remarks/Arguments begin on page 2 of this paper.